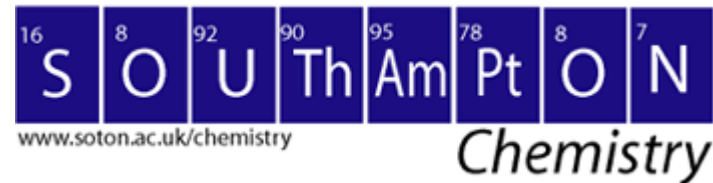


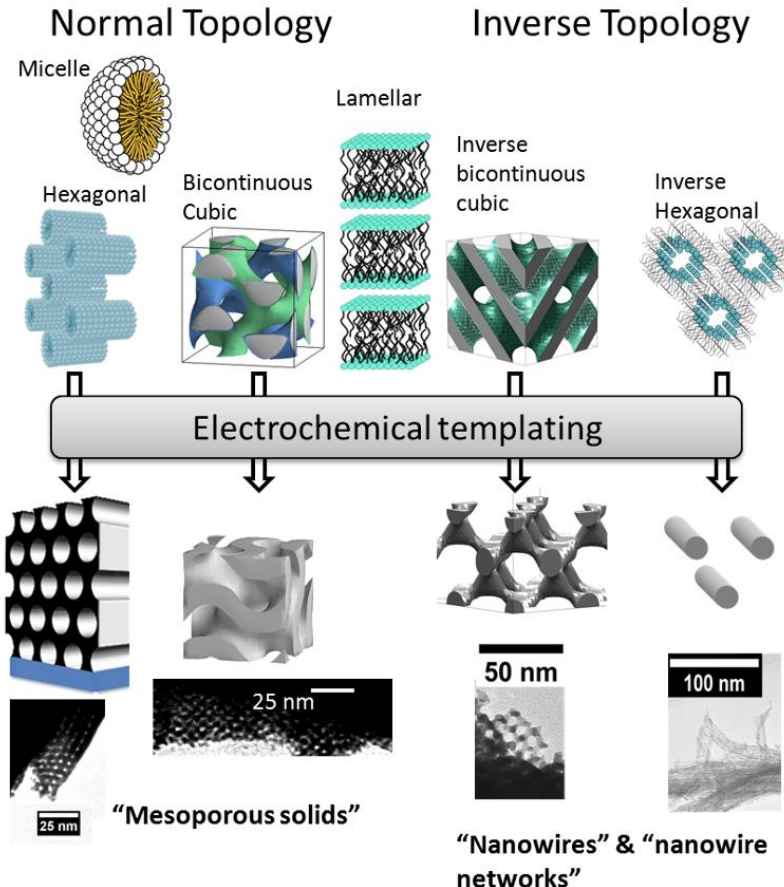
Dr Iris Nandhakumar

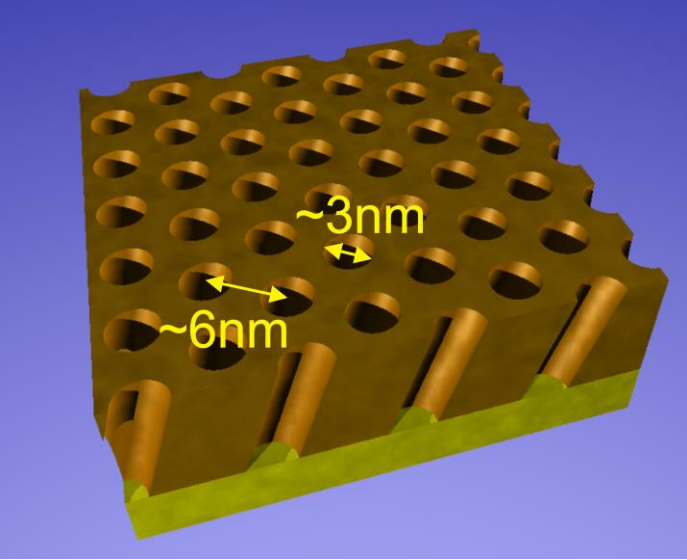
University of Southampton

iris@soton.ac.uk



Soft-templating of 3D metamaterials





- Unique 3D nanostructuring
- High quality birefringent semiconductors
- Engineered metamaterials: e.g. CdTe, PbTe, Te...

- 40 % of all the atoms are at or near a surface:
 - Enhanced electronic + optical properties for e.g. solar cells, ultra-fast photodiodes, non-linear optical elements

 - Exploration of quantum-size effect

Chem. Comm., Vol. 12, 1374-1375
(2004)

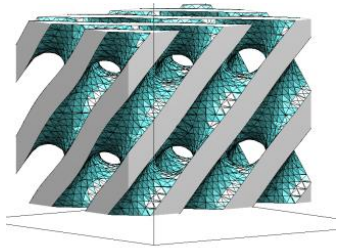
Appl. Phys.Lett., Vol. 86, 011912
(2005)

J. Mat. Chem., 16 (31): 3207-3214
2006

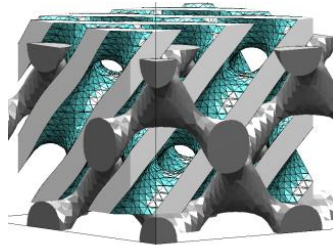
*Electrochem. Comm.*10, 363 (2008)

3D Nanostructured Thermoelectric Metamaterials

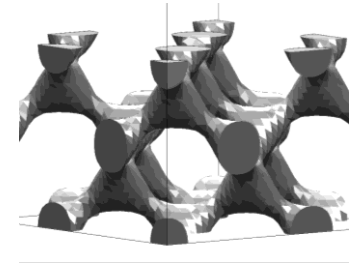
Soft Template



Electrochemical
Deposition

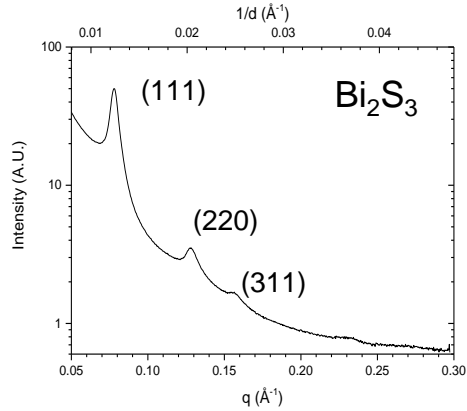


Removal of template



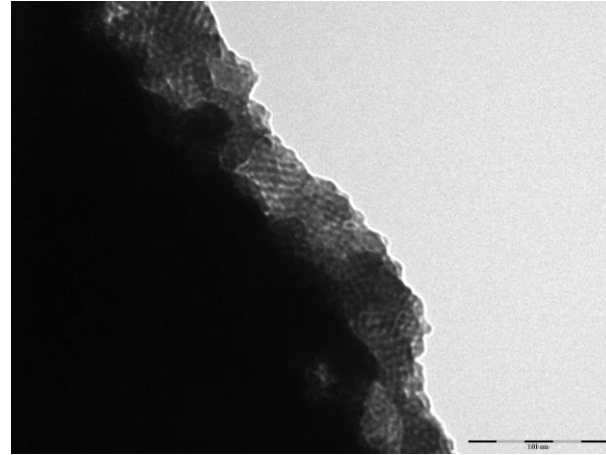
3D Nanostructure

SAXS



“Single-diamond”

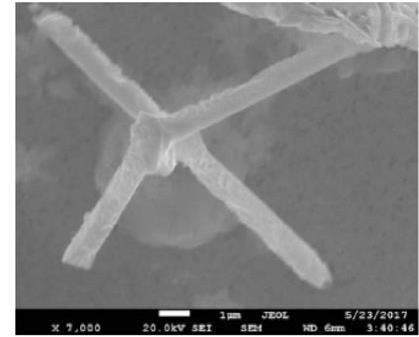
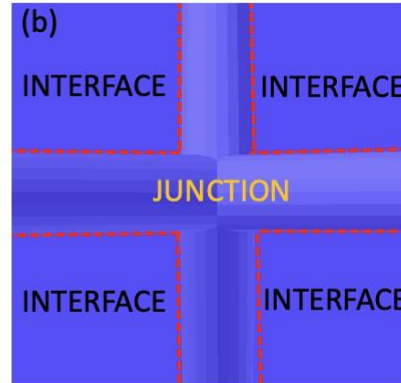
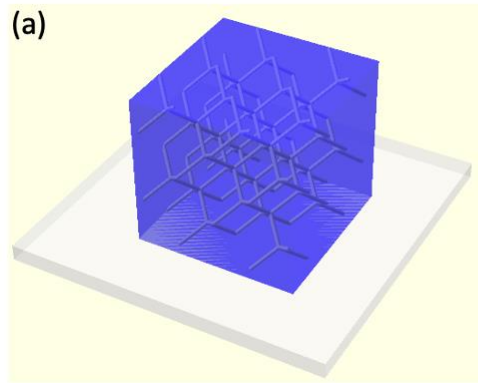
TEM



Electrochemistry Communications 97, 56-59 (2018).
Scientific Reports 7, 6405 (2017).
Electrochem. Comm 76, 71-74 (2017).

3D Thermal metamaterials

EPSRC: EP/X012840/1



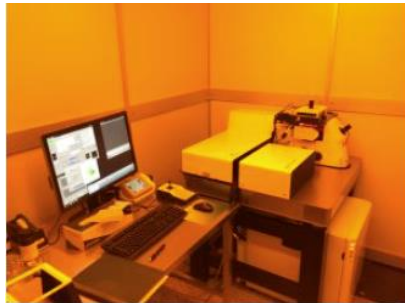
3D Nanoscale Metamaterials: Cardiff University

Principle Investigator



Dr Sam Ladak

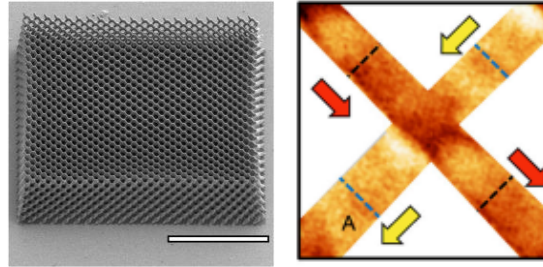
Key Instrumentation



Modified Nanoscribe system:
Sub-100nm feature size
(Unique in U.K.)

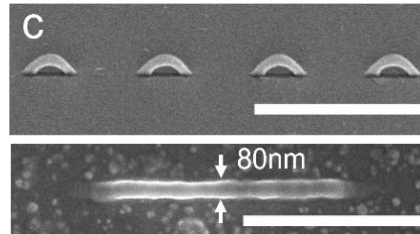
Expertise and interests

May et al. Nature Comms 3217 (2021)



3D Magnetic Metamaterials:
Static and magnonic properties

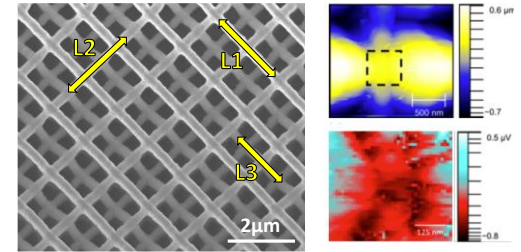
EPSRC: EP/R009147/1



Low Energy Racetrack Memories
On-chip

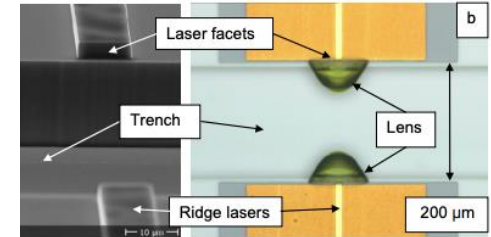
LadakS@Cardiff.ac.uk

EPSRC: EP/X012735/1



3D Thermal Metamaterials: Controlling
thermal conductivity

Thomas et al. Optics Express 26 13436 (2018)



Lab-on-chip Micro-optics
On-chip micro-lenses

LEVERHULME
TRUST

EPSRC

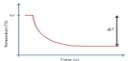
Developing Rapid Mesoscale Thermoelectric Property Measurement System

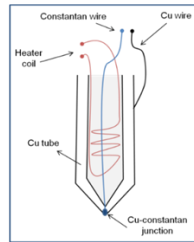
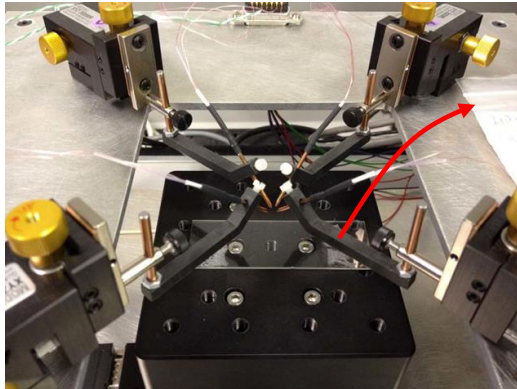
- Gao Min and Matthew Philips, School of Engineering, Cardiff University -

Established Systems @ millimetre scale

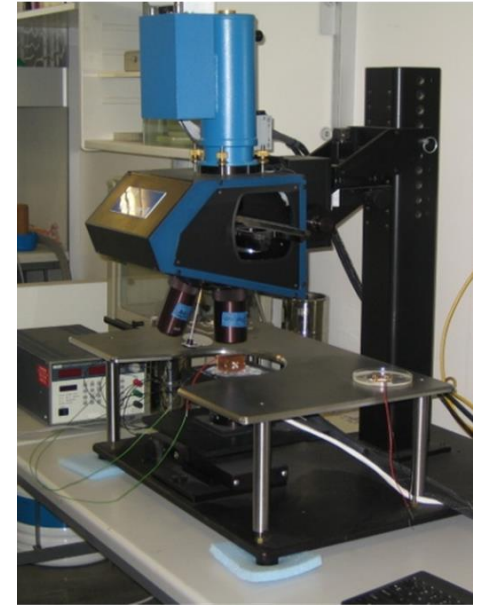
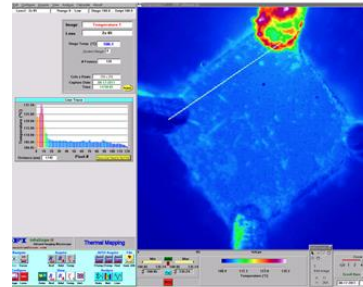
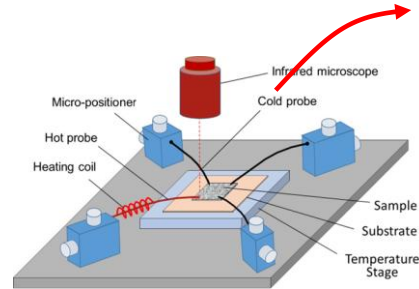
Seebeck coefficient: $\alpha_s = \frac{\Delta V}{\Delta T} + \alpha_b \quad \pm 2\%$

Electrical resistivity: $\rho = \left(\frac{\pi R_{av}}{\ln 2} \right) \times d \quad \pm 3\%$

Thermal conductivity:  $\pm 12\%$



New System on Infrascopie @ mesoscale



“Multifunctional probes for high-throughput measurement of Seebeck coefficient and electrical conductivity”, *Rev. Sci. Instrum.*, (2014), 85, 043906

“Apparatus for measuring Seebeck coefficient and electrical resistivity of small dimension samples using infrared microscope as temperature sensor”, *Rev. Sci. Instrum.*, (2013), 84, 054903